



## UNITED STATES PATENT AND TRADEMARK OFFICE

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UNITED STATES PATENT AND TRADEMARK OFFICE  
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Bib Data Sheet

## CONFIRMATION

SERIAL NUMBER 09/848,577	FILING DATE 05/03/2001 RULE	CLASS 118	GROUP ART UNIT 1763	ATTORNEY DOCKE YPL-06
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## APPLICANTS

Young-Hoon Park, Kyungki-do, KOREA, REPUBLIC OF;

## \*\* CONTINUING DATA \*\*\*\*\*

NONE *mu* 9/8/04

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

REPUBLIC OF KOREA 00-35102 06/24/2000

*mu* 9/8/04

## IF REQUIRED, FOREIGN FILING LICENSE

GRANTED \*\* 06/27/2001

\*\* SMALL ENTITY \*\*

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 8 <i>✓</i>	TOTAL CLAIMS 17 <i>✓</i>	INDEPENDENT CLAIMS 1 <i>✓</i>
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after				
Verified and Acknowledged Examiner's Signature <i>Alowance</i> Initials				

## ADDRESS

Cantor Colburn LLP  
55 Griffin South Road  
Bloomfield, CT 06002

## TITLE

Reactor for depositing thin film on wafer

FILING FEE RECEIVED 355	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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